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First Named Inventor

Kazuhiko OMOTE

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Examiner Name

Krystyna Suchecki

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OTHER PRIOR ART - NON-PATENT LITERATURE DOCUMENTS

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Cite
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Include name of author (in CAPITAL LETTERS), title of article, title of item, date, page(s), volume-issue number(s), publisher, city and/or country where published

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R. Baudoing-Savois, et al., "A new UHV diffractometer for surface structure and real time molecular beam deposition studies with synchrotron radiations at ESRF," Nuclear Instruments and Methods in Physics Research B 149 (1999), pp. 213-227



H. Oyangi, et al., "A new apparatus for surface x-ray absorption and diffraction studies using synchrotron radiation," Review of Scientific Instrument 66, December, 1995, Woodbury, New York, U.S.A., pp. 5477-5485

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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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